Docket No. 500.39826CX1/E5828-04EU

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Seiichiro KANNO et al.

Serial No. : Unassigned (§53(b) Cont. of 09/799,527 filed 3/7/2001)

Filed: 07 October 2003

For : SEMICONDUCTOR MANUFACTURING APPARATUS

AND METHOD OF PROCESSING SEMICONDUCTOR WAFER USING PLASMA AND WAFER VOLTAGE PROBE

Art Unit : Unassigned (Parent - 1763)

Examiner: Unassigned (Parent - Ram N. Kackar)

Conf. No. : Unassigned (Parent - 4591)

## INFORMATION DISCLOSURE STATEMENT

## Mail Stop Patent Application Commissioner for Patents

POB 1450

Alexandria, Virginia 22313-1450

7 October 2003

Sir:

In the matter of the above-identified application, Applicant hereby submits the attached information for consideration by the Office under 37 C.F.R. §§1.97 and 1.98, as listed on the accompanying Form PTO-1449.

The present application is a continuation of Serial No. 09/799,527 filed 7 March 2003, pending. The information listed on the attached Form PTO-1449 was previously cited by or submitted to the Office in the prior application. Therefore, in accordance with 37 CFR §1.98(d), no copies of the listed references are required. Further, in accordance with 37 CFR §1.98(3)(i), a concise explanation of relevance or translation was submitted in the prior application for each item of information not in the English language, and as indicated in MPEP §609A(3), no separate concise

KANNO et al., §53b of SN 09/799,527 Prelim. Amd. filed 10/07/2003

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explanation of relevance is required because the relevance of the information does not differ from its relevance as explained in the prior application.

This Information Disclosure Statement is being filed concurrently with the above-identified application or within three (3) months of the filing date, and is therefore timely, and no Petition or fee is possible or required for this submission.

Respectfully submitted,

Paul J. Skwierawski

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							Seiichiro KANNO et al.					
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